

<b>Notice of References Cited</b>	Application/Control No. 10/711,035		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner W. Patty Chen		Art Unit 2871	Page 1 of 1

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*	B	US-2004/0263767	12-2004	Wang et al.	349/158
*	C	US-7,086,175	08-2006	Sasaki et al.	34/92
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**NON-PATENT DOCUMENTS**

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